

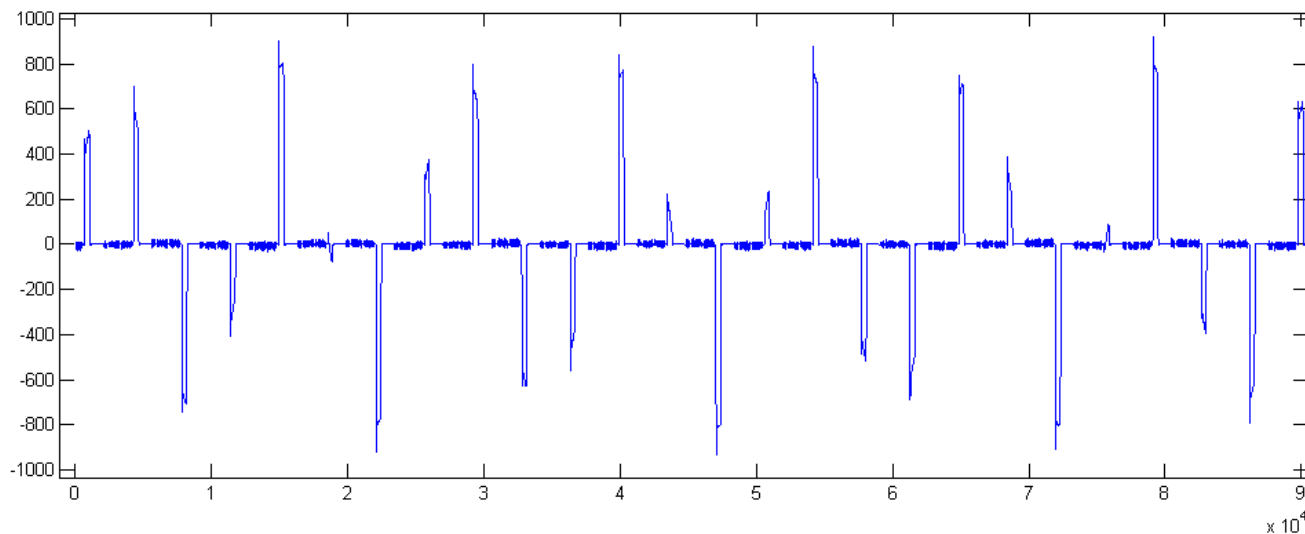
# Abort gap cleaning: status at 450 GeV and issues/plans at 3.5 TeV

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Thanks to D. Jacquet, V. Kain et al.

# Abort gap & Injection gap cleaning

- Cleaning mode – ADT excites the beam which then hits the collimators
- Excitation:
  - in a defined time window (abort gap, next injection slot)
  - by a synthesized signal (currently sinusoidal (various modulations available), noise is being studied)



Signals  
acquired during  
injection of the  
fill #1867

# ADT performance

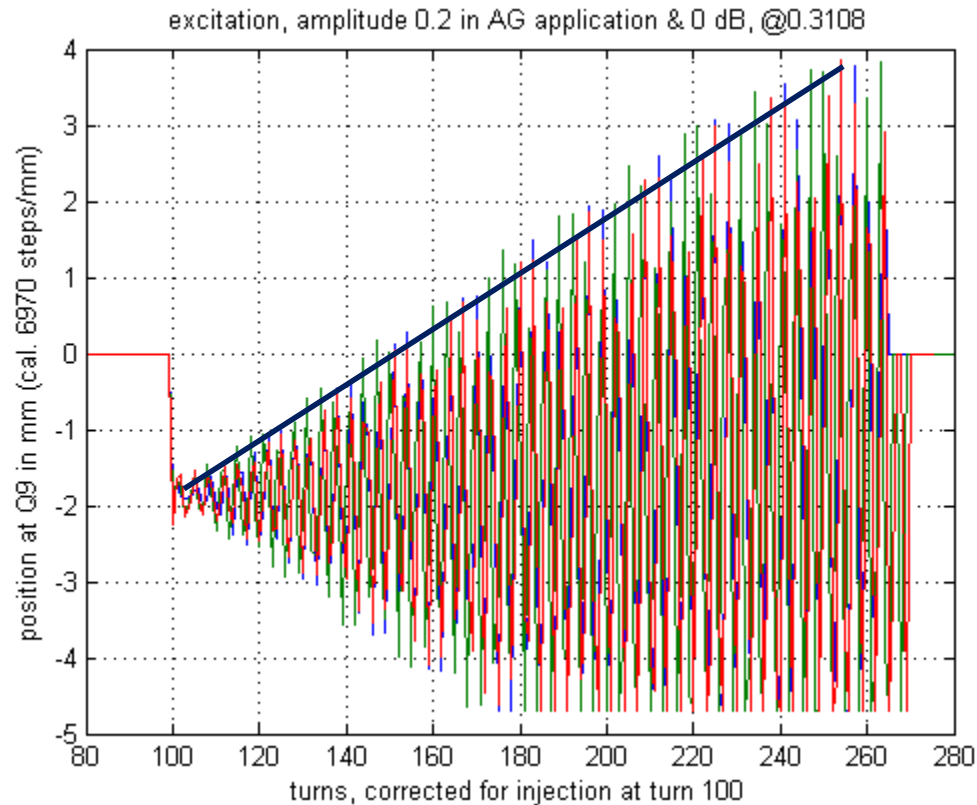
- Excitation amplitude currently at 10% of the available kick strength (scales with the damper electronic gain)

LHC ADT performance in LHC optics version 6.5xxx compared to original assumptions (at 450 GeV/c), assuming 7.5 kV maximum kick voltage

	$\beta=100$ performance	Optics 6.4 performance	New Optics	
	Kick per turn in $\sigma$	Kick per turn in $\sigma$ @ $\beta$ in m		
ADTH beam 1	0.2 $\sigma$	0.277 $\sigma$ at $\beta=193$ m	0.317 s	252 m
ADTH beam 2	0.2 $\sigma$	0.273 $\sigma$ at $\beta=187$ m	0.253 s	160 m
ADTV beam 1	0.2 $\sigma$	0.309 $\sigma$ at $\beta=239$ m	0.285 s	203 m
ADTV beam 2	0.2 $\sigma$	0.316 $\sigma$ at $\beta=250$ m	0.386 s	305 m

# ADT performance

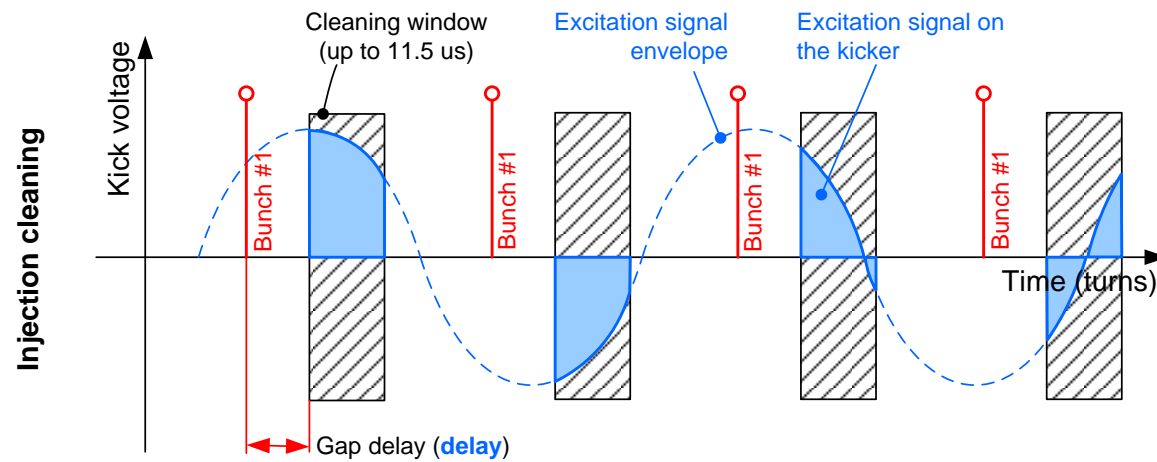
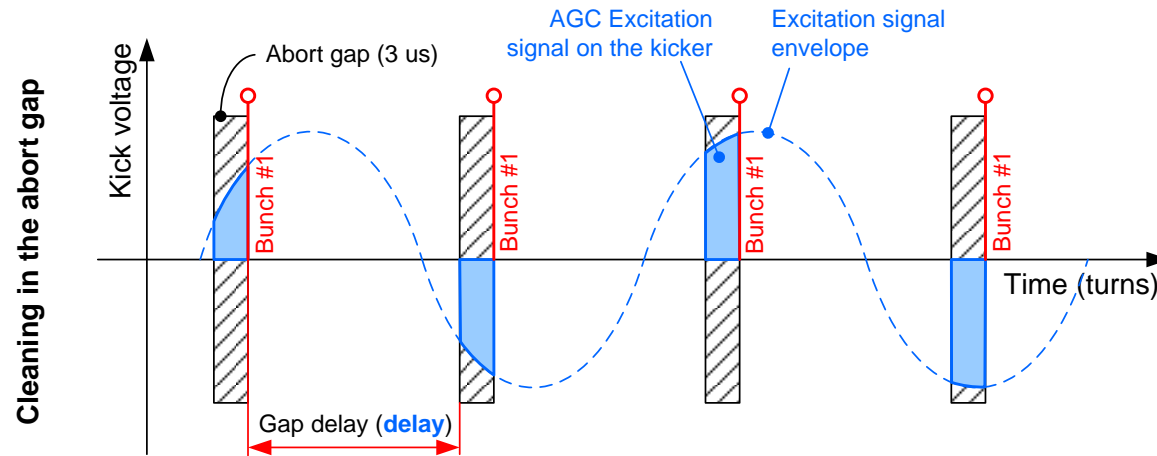
Beam 2, Q9 vertical Abort Gap Cleaning tests 30. 4. 2010



slope: 0.0387 mm/turn @ 1/10 of strength  
(6 mm from turn 95 to 250)

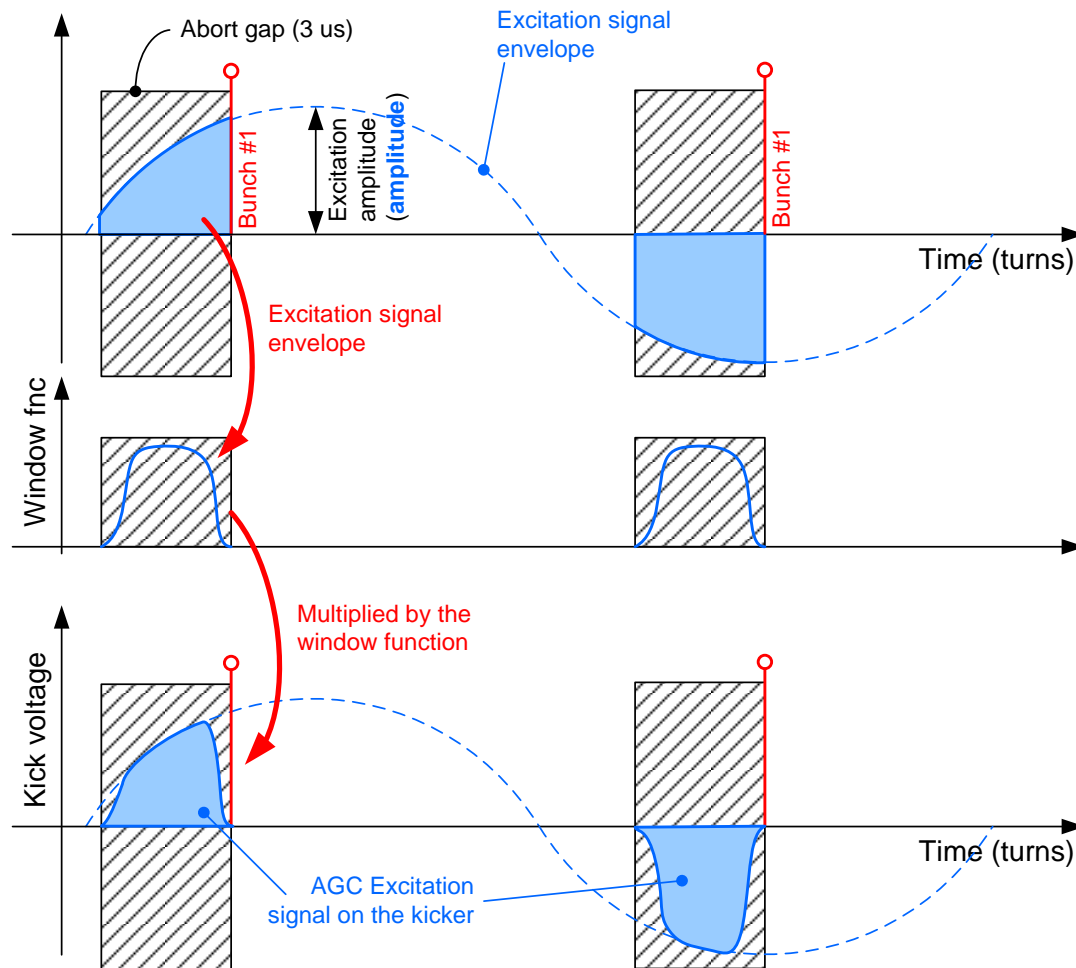
# Cleaning signal generation

- Excitation within the turn



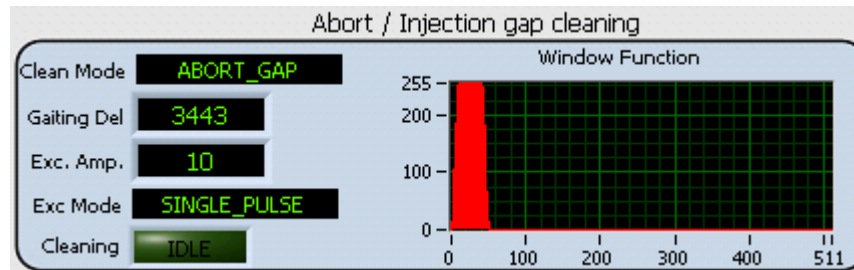
# Cleaning signal generation

- Window function



# Abort gap cleaning

- **Abort gap cleaning sequence**
  - Coherent excitation at  $Q_{\text{VER}} \pm 0.01$  in 15 steps (750 turns/step)
  - Triggered by the 1000 ms timing
  - Sequence stops automatically after 11240 turns



# Abort gap cleaning

- **Operation**

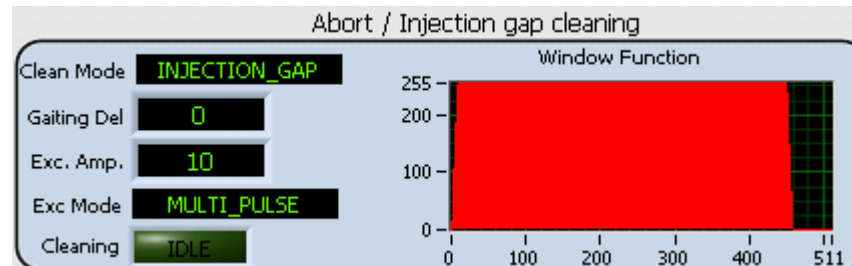
1. **Sequencer sets the cleaning parameters** for flat bottom. Drive all non critical, check all critical.
2. **Inject pilot**
3. **AGC activated** by task enabling the timing before injecting first nominal
4. **Injecting physics beam**. Cleaning sequence is retriggered by timing every second
5. **AGC deactivated** in the sequence prepare for ramp by disabling the timing (+ setting key parameters to zero)



# Injection gap cleaning

- **Injection gap cleaning sequence**

- Cleaning bucket programmed on-the-fly by the injection sequencer
- Triggered by software (injection sequencer, could be protected by RBAC)
- Coherent excitation at  $Q_{\text{HOR}} \pm 0.01$  in 15 steps (750 turns/step)
- One sub-sequence is 11240 turns long
- Sub-sequence repeats up to 20 times
- Cleaning sequence redundantly stopped by two timings and software



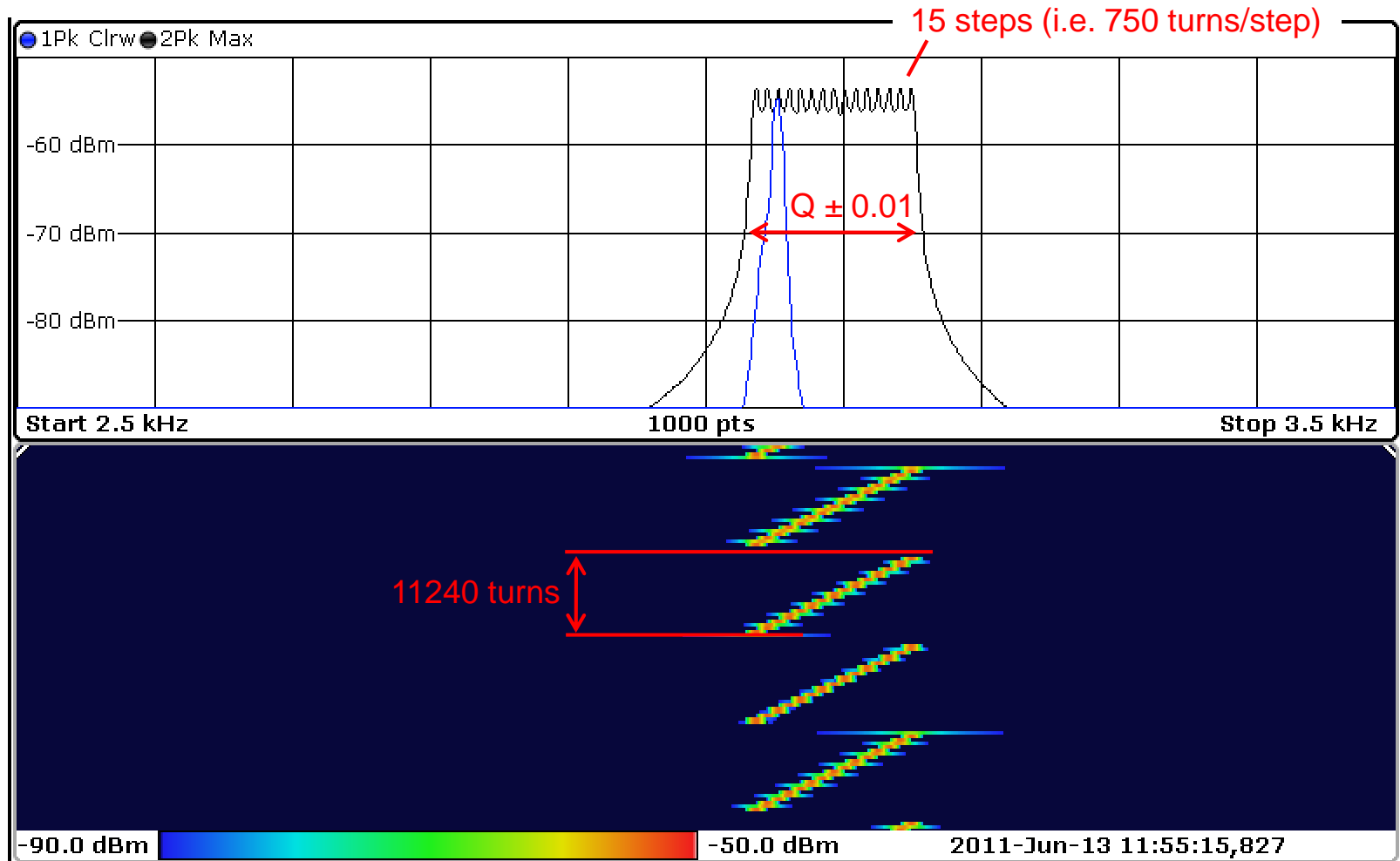
# Injection gap cleaning

- **Operation**

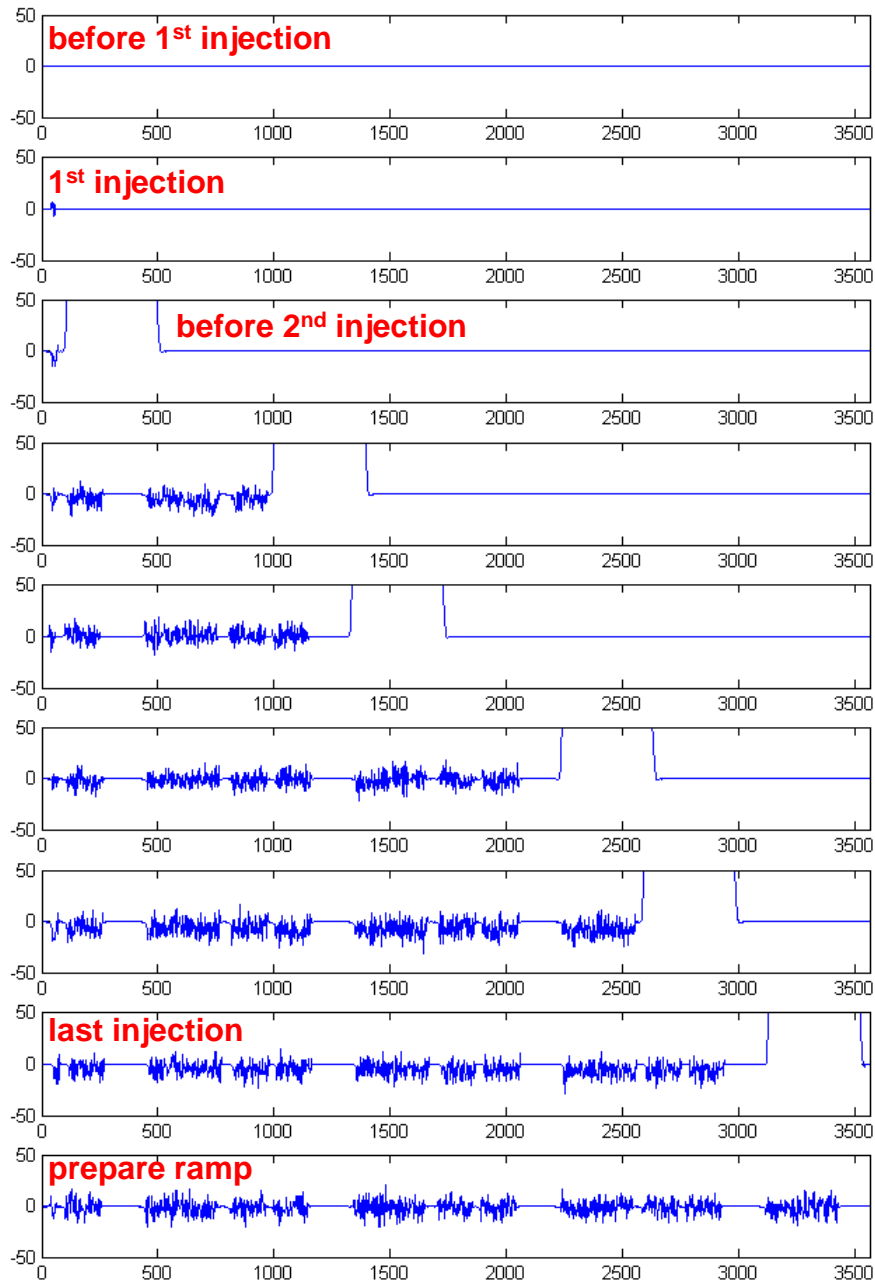
1. **Sequencer sets/checks the cleaning parameters**
2. **Inject pilot**
3. After inj. the **Injection sequencer checks the next injection bucket** and programs the next cleaning bucket
4. **Injection sequencer starts the cleaning** as soon as the CBCM has accepted the injection request (typ. one SPS cycle)
5. **Cleaning sequence is running**
6. **Cleaning is stopped** 3 ms before the injection **by Injection forewarning timing** and redundantly 2 turns before injection by the BeamIn trigger
7. **Cleaning stopped by the Injection sequencer** after injection (even empty inj.)
8. **Cleaning times out in hardware** after 20 sequences (20 x 1s) had been played
9. **Go to step 2**
10. **Sequencer disables cleaning** by setting key parameters to zero **at Prepare ramp**

# Cleaning sequence

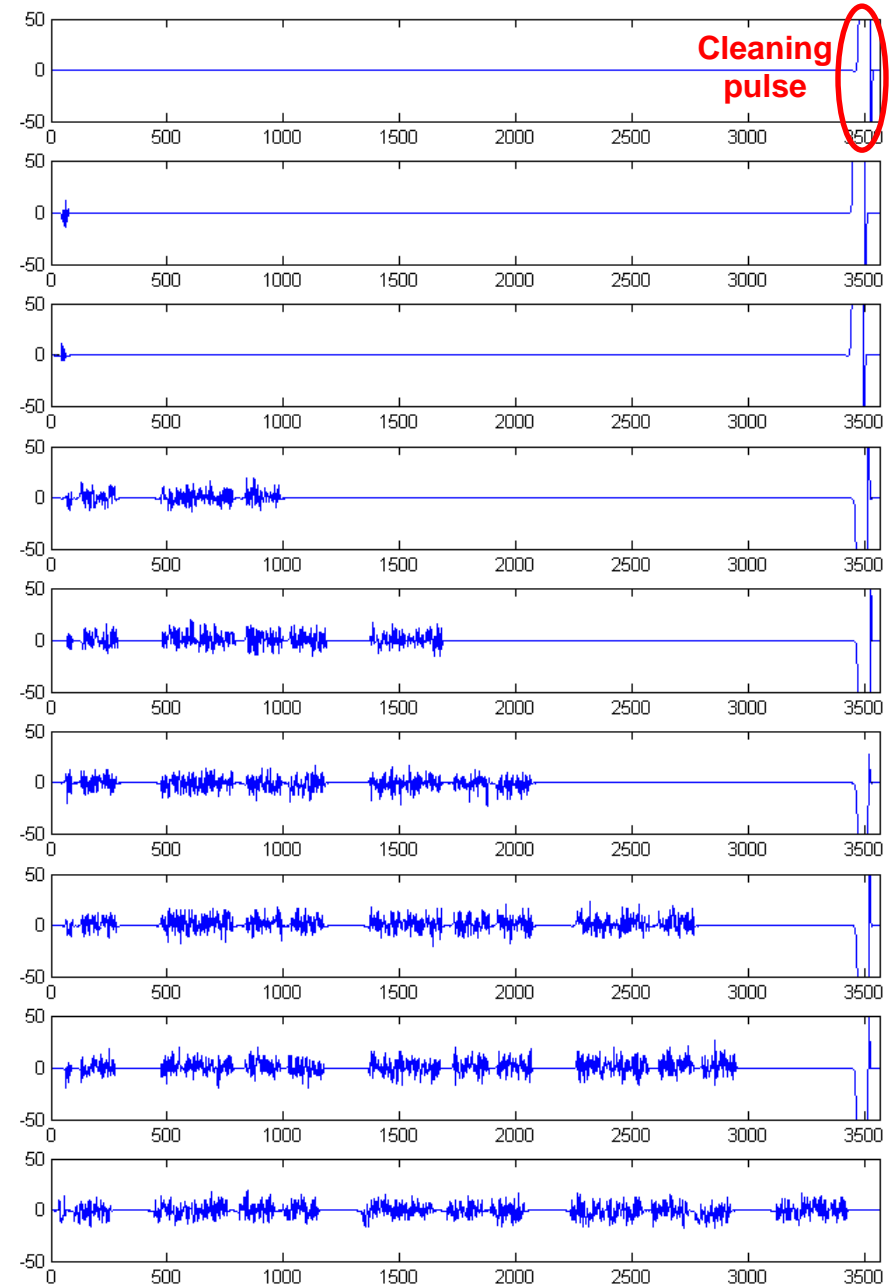
- Abort gap cleaning sequence



# Injection gap cleaning (hor. plane)



# Abort gap cleaning (ver. plane)



# Current status

- Sequencer drives the settings at injection
- All cleaning settings are static:
  - Set of regular LSA settings (frequency, exc. mode, amplitude etc.)
  - Critical settings (Gating, Gating offset, Gating delay, Clean mode)
- Some settings will be different for 3.5 TeV operation
  - Tune values
  - Excitation mode, amplitude, cleaning sequence
  - Window function (?)
- Critical settings are identical for injection and flat top
- **Cleaning is not compatible with the tune measurement**

# To do (for the next technical stop)

- Delphine already created different users for AGC
  - LHC.INJ\_ADT (settings for injection)
  - LHC.FT\_ADT (settings for flat top)
- The actual parameter settings are not user dependent
- The AGC control application needs to be updated
- The sequencer needs to be updated

# To do...

- Agreement on the cleaning strategy at flat top with 70+ MJ in the machine
  - When and how to start the cleaning
  - What type of excitation to use
  - Must avoid sudden high losses when we start to clean (beam dump)



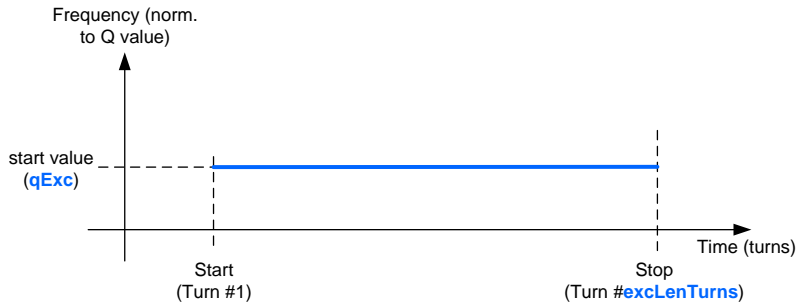
# Summary

- Abort gap / Injection gap cleaning routinely used at injection
- No technical issues to run the cleaning at flat top
- A set of multiplexed settings was already created to program the parameters for injection/flat top
- **Need to agree on cleaning strategy at flat top**
- **Input from the machine protection!**

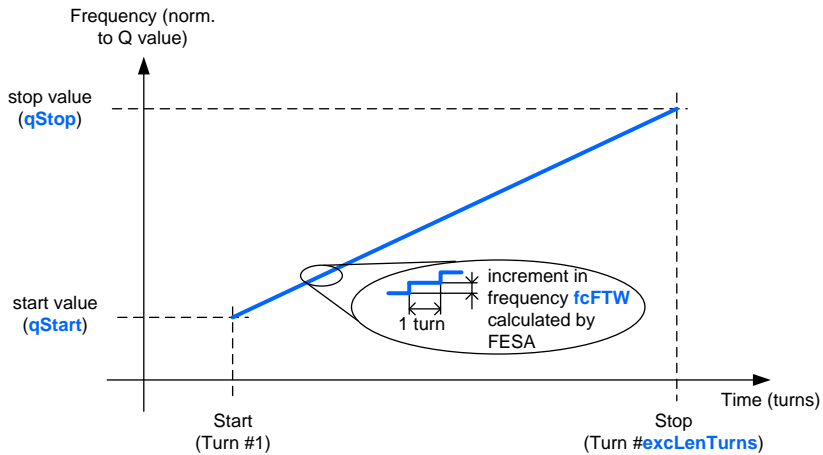


# Abort gap & Injection gap cleaning

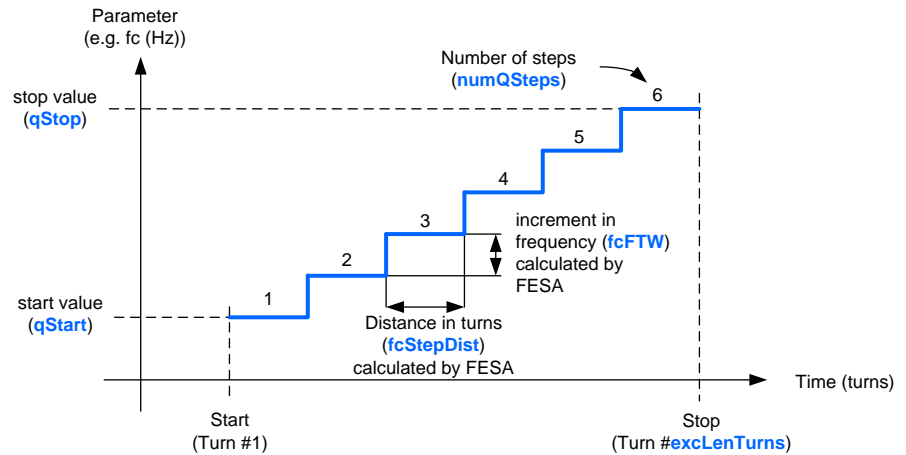
Fixed frequency excitation mode



Continuous frequency excitation mode

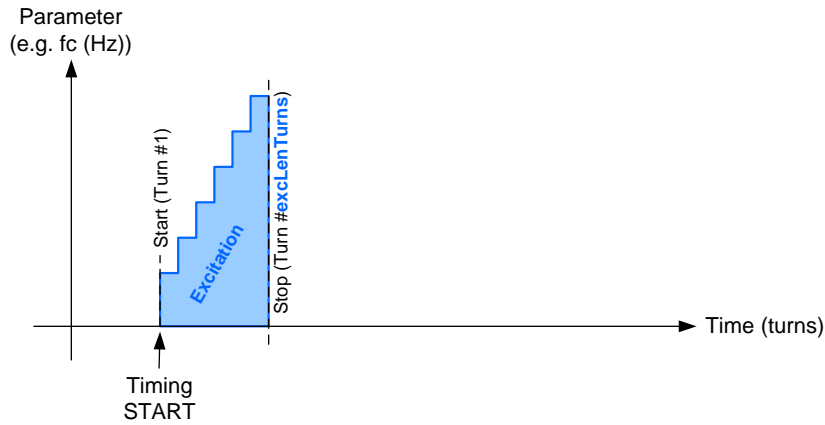


Stepped frequency excitation mode

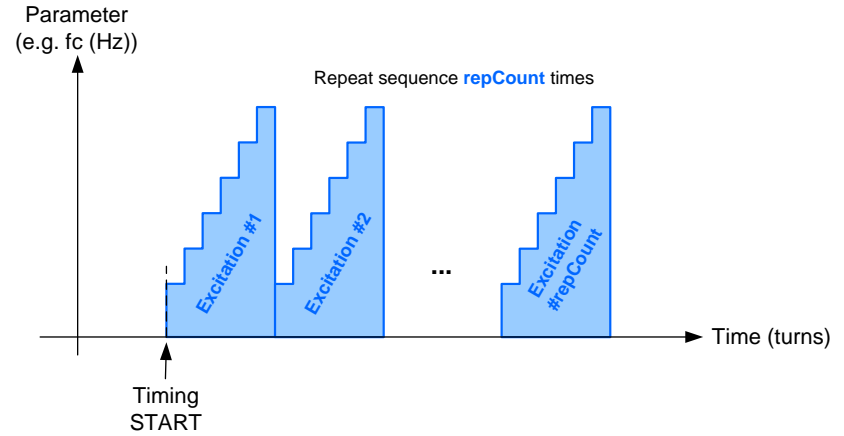


# Cleaning sequence

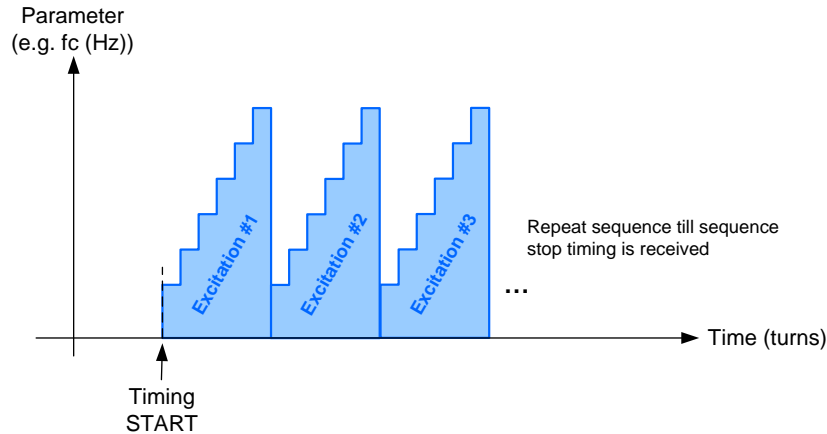
Single pulse sequence mode



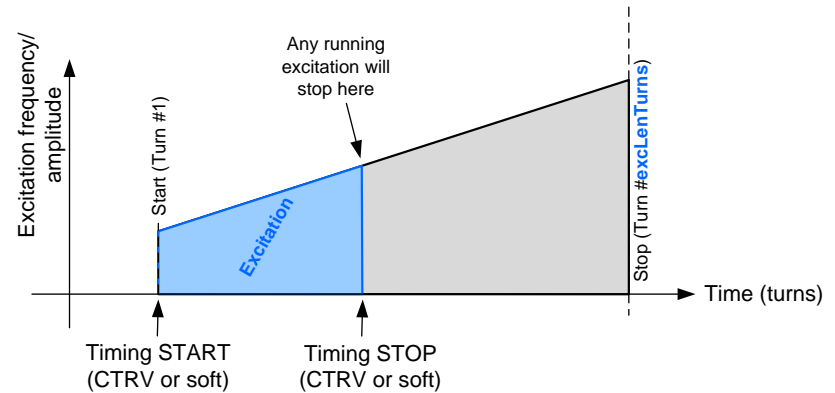
Multi pulse sequence mode



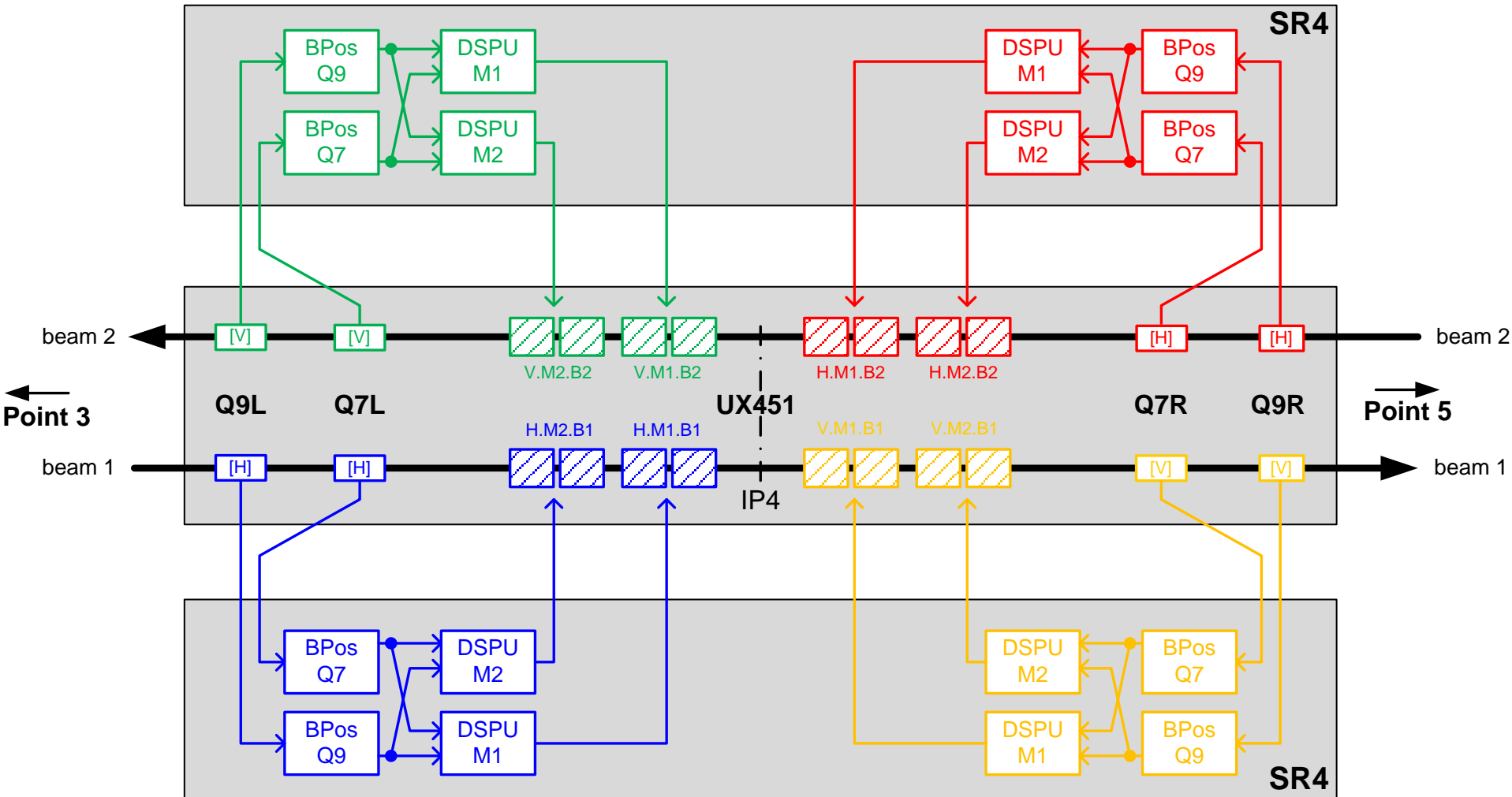
Continuous sequence mode



Start/Stop sequence by timing



# ADT layout in the machine



Bpos – Beam Position Module  
 DSPU – Digital Signal Processing Unit